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PATENT  
Customer No. 22,852  
Attorney Docket No. 04329.2306

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Yoshio Ozawa et al. ) Group Art Unit: 2823  
Application No.: 09/559,757 ) Examiner: Pham, Thanh V.  
Filed: April 27, 2000 ) Confirmation No. 2923  
For: METHOD OF MANUFACTURING )  
A SEMICONDUCTOR DEVICE )  
USING AN OXIDATION PROCESS )

**MAIL STOP AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**PETITION FOR EXTENSION OF TIME**

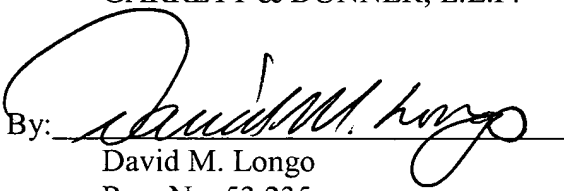
Applicants hereby petition for a one-month extension of time to reply to the Final Office Action mailed June 28, 2005. A fee of \$ 120 is enclosed.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

Dated: October 25, 2005

By:   
David M. Longo  
Reg. No. 53,235

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